
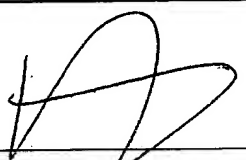


|   |                        |         |                                |       |               |                |
|---|------------------------|---------|--------------------------------|-------|---------------|----------------|
| LIST OF PUBLICATIONS/MATERIALS<br>CITED BY APPLICANT  |                        |         | Attorney Docket No.<br>SEL 126 |       | Serial No.    |                |
|   |                        |         | Applicant<br>Yamazaki et al.   |       |               |                |
|   |                        |         | Filing Date<br>herewith        |       | Group         |                |
| <div style="text-align: right;">             JCS18 U.S. PRO<br/>             09/26/99<br/> <br/>             03/04/99           </div> |                        |         |                                |       |               |                |
| U.S. PATENT DOCUMENTS   |                        |         |                                |       |               |                |
| *EXAMINER<br>INITIAL  | DOCUMENT<br>NUMBER     | DATE    | NAME                           | CLASS | SUB-<br>CLASS | FILING<br>DATE |
| MP  | 5,648,277              | 7/15/97 | Zhang, et al.                  | 437   | 21            |                |
| MP  | 5,648,824 <sup>6</sup> | 7/01/97 | Ohtani, et al.                 | 437   | 88            |                |
| MP  | 5,829,443<br>5         | 1/12/99 | Yamazaki, et al.               | 257   | 65            |                |
| FOREIGN PATENT DOCUMENTS  |                        |         |                                |       |               |                |
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| MP  | 09-312260              | 12/2/97 | Japan                          | —     | —             | —              |

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| OTHER PUBLICATIONS/MATERIALS<br>(Including Author, Title, Date, Pertinent Pages) |  |
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| LIST OF PUBLICATIONS<br>CITED BY APPLICANT | <u>Attorney Docket No.</u><br>SEL 126      | <u>Serial No.</u><br>09/262,657      |
|  | <u>Applicant</u><br>Shunpei YAMAZAKI et al |                                      |
|  | <u>Filing Date</u><br>March 4, 1999        | <u>Group</u><br><del>2811</del> 2822 |

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| *EXAMINER<br>INITIAL | DOCUMENT<br>NUMBER | DATE     | NAME           | CLASS | SUB-<br>CLASS | FILING<br>DATE |
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| MP | King, T.J. et al, "Polycrystalline Silicon-Germanium Thin-Film Transistors," <i>IEEE Transactions on Electron Devices</i> , vol. 41, no. 9, pp. 1581-1591, September, 1994.   |
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